

## Message Text

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20

ORIGIN EB-07

INFO OCT-01 CIAE-00 COME-00 DODE-00 NRC-05 NSAE-00 USIA-06

TRSE-00 EUR-12 ERDA-05 ISO-00 NEA-10 ACDA-07 /053 R

DRAFTED BY EB/ITP/EWT:LROSS

APPROVED BY EB/ITP/EWT:RWPRACHT

COMMERCE/OEA:MHUTCHINSON

DEFENSE/OSD:DSCHROEDER

RPE

----- 024184

P 272310Z SEP 76

FM SECSTATE WASHDC

TO USMISSION OECD PARIS PRIORITY

C O N F I D E N T I A L STATE 240188

EXCON

E.O. 11652: XGDS-1

TAGS: ESTC, COCOM, GW, UR

SUBJECT: GERMAN EQUIPMENT AND TD FOR MA,UFACTURE OF  
SILICON AND THYRISTORS TO USSR - IL 1355

REF: COCOM DOC (76)1330

CONTINUE RESERVE AND REQUEST TECHNICAL SPECIFICATIONS OF  
THE POWER THYRISTOR DEVICE(S) TO OE MANUFACTURED AND OF THE  
FOLLOWING EQUIPMENT (ITEM NUM0ERS REFER TO THE NUMBERS ON  
THE EQUIPMENT LIST SUPPLIED BY T'E GERMANS):

ITEM 2.1 (FLOAT ZONE MACHINE); 2.16 (TWO-TU3E DIFFUSION FUR-  
NACE) - PLEASE STATE SPECIFIC USE IN THE MANUFACTURE OF  
SILICON; 3.9 (ETCHING EQUIPMENT); 3.10 (LAPPING MACHINE  
WITH MEASURING -YTEM); 5.7 (EXPOSURE EQUIPMENT);  
6.8 (VACUUM HEATING EQUIPMENT); 6.15 (IG -VACUUM ALLOY-  
ING EQUIPMENTS); 7.5 (VAPORIZATION PLANT); 10.1, 10.2,  
10.3, 10.4 AND 10.5 (DEVICE TEST EQUIPMENT); 11.5 (VACUUM  
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HEATING SYSTEM); 11.10 (MOUNTING EQUIPMENT); 13.9 (IN-

TERFERENCE MEASUREMENT EQUIPMENT); 15.1 (STAMPING TOOL);  
15.2 (LAPPING MACHINE); 15.4 (GALVANICING PLANT); 15.5  
(HARDENING FURNACE); 15.6 (STAMPING TOOL). KISSINGER

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NNN

## Message Attributes

**Automatic Decaptioning:** X  
**Capture Date:** 01 JAN 1994  
**Channel Indicators:** n/a  
**Current Classification:** UNCLASSIFIED  
**Concepts:** STRATEGIC TRADE CONTROLS, EXPORT LICENSES, END USE CHECKS, ELECTRIC EQUIPMENT  
**Control Number:** n/a  
**Copy:** SINGLE  
**Draft Date:** 27 SEP 1976  
**Decaption Date:** 01 JAN 1960  
**Decaption Note:**  
**Disposition Action:** RELEASED  
**Disposition Approved on Date:**  
**Disposition Authority:** BoyleJA  
**Disposition Case Number:** n/a  
**Disposition Comment:** 25 YEAR REVIEW  
**Disposition Date:** 28 MAY 2004  
**Disposition Event:**  
**Disposition History:** n/a  
**Disposition Reason:**  
**Disposition Remarks:**  
**Document Number:** 1976STATE240188  
**Document Source:** CORE  
**Document Unique ID:** 00  
**Drafter:** LROSS  
**Enclosure:** n/a  
**Executive Order:** X1  
**Errors:** N/A  
**Film Number:** D760365-0075  
**From:** STATE  
**Handling Restrictions:** n/a  
**Image Path:**  
**ISecure:** 1  
**Legacy Key:** link1976/newtext/t19760915/aaaaamrt.tel  
**Line Count:** 64  
**Locator:** TEXT ON-LINE, ON MICROFILM  
**Office:** ORIGIN EB  
**Original Classification:** CONFIDENTIAL  
**Original Handling Restrictions:** n/a  
**Original Previous Classification:** n/a  
**Original Previous Handling Restrictions:** n/a  
**Page Count:** 2  
**Previous Channel Indicators:** n/a  
**Previous Classification:** CONFIDENTIAL  
**Previous Handling Restrictions:** n/a  
**Reference:** n/a  
**Review Action:** RELEASED, APPROVED  
**Review Authority:** BoyleJA  
**Review Comment:** n/a  
**Review Content Flags:**  
**Review Date:** 26 APR 2004  
**Review Event:**  
**Review Exemptions:** n/a  
**Review History:** RELEASED <26 APR 2004 by CollinP0>; APPROVED <12 AUG 2004 by BoyleJA>  
**Review Markings:**

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EO Systematic Review  
04 MAY 2006

**Review Media Identifier:**  
**Review Referrals:** n/a  
**Review Release Date:** n/a  
**Review Release Event:** n/a  
**Review Transfer Date:**  
**Review Withdrawn Fields:** n/a  
**Secure:** OPEN  
**Status:** NATIVE  
**Subject:** GERMAN EQUIPMENT AND TD FOR MA,UFACTURE OF SILICON AND THYRISTORS TO USSR - IL 1355  
**TAGS:** ESTC, GE, UR, US, COCOM  
**To:** OECD PARIS  
**Type:** TE  
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